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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **MARUYAMA, Kenji, et al.**

Group Art Unit: **2891**

Serial No.: **10/532,249**

Examiner: **FULK, Steven J.**

Filed: **April 22, 2005**

P.T.O. Confirmation No.: **1069**

For: **METHOD OF PRODUCING SEMICONDUCTOR DEVICE**

**RESPONSE UNDER 37 CFR §1.116**  
**- EXPEDITED RESPONSE -**  
**GROUP ART UNIT 2891**

**MAILSTOP AF**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

February 20, 2009

Sir:

In response to the Office Action dated **November 26, 2008**, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims, which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.